



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

June 29, 2026

IGI Report Number

LG800615535

Description

LABORATORY GROWN DIAMOND

Shape and Cutting Style

OLD EUROPEAN CUT

Measurements

6.36 - 6.38 X 3.96 MM

GRADING RESULTS

Carat Weight

1.04 CARAT

Color Grade

E

Clarity Grade

VVS 2

ADDITIONAL GRADING INFORMATION

Polish

EXCELLENT

Symmetry

EXCELLENT

Fluorescence

NONE

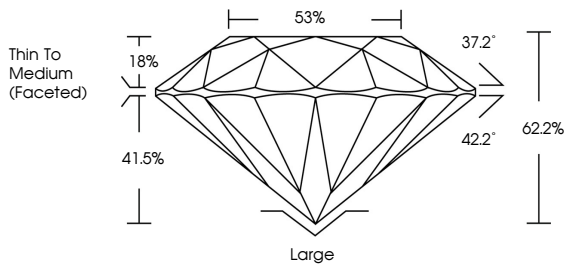
Inscription(s)

 LG800615535

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

Report verification at igi.org

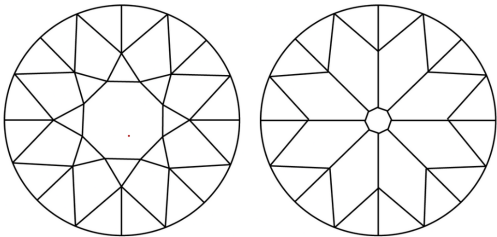
PROPORTIONS



Thin To Medium (Faceted)

Large

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL IF VVS 1-2 VS 1-2 SI 1-2 I 1-3

Flawless Internally Flawless Very Very Slightly Included Very Slightly Included Slightly Included Included



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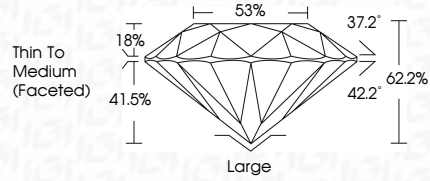
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OLD EUROPEAN CUT

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Carat Weight

1.04 CARAT

Color Grade

E

Clarity Grade

VVS 2

Depth

62.2%

Table

85%

Graile

Thin To Medium (Faceted)

Culet

Large

Polish

EXCELLENT

Symmetry

EXCELLENT

Fluorescence

NONE

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